

RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 1700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Smith, *et al.* Docket No.: 2001 P 11900 US01
Serial No.: 10/786,996 Art Unit: 1746
Filed: February 25, 2004 Examiner: Markoff, Alexander
For: Method of Removing PECVD Residues of Fluorinated Plasma Using In-Situ H₂ Plasma

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RESPONSE UNDER 37 CFR § 1.116

Dear Sir:

Applicants respectfully submit the following amendments and remarks in response to Examiner's Office Action dated May 17, 2006, which Action is made final. Applicants respectfully request that these amendments and remarks be entered in pursuant to the provisions of 37 CFR § 1.116, and respectfully request reconsideration of claim 8.

OK to enter
8/10/06
Jell